

DOCKET NO.: 211603US20

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Ghassan E. JABBOUR

SERIAL NO.: New Application

FILED: Herewith

FOR: VAPOR DEPOSITION AND IN-SITU PURIFICATION OF ORGANIC
MOLECULES

REQUEST FOR SMALL ENTITY STATUS

This application qualifies for small entity status.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.



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Date:

July 31, 2001



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LIST OF INVENTORS' NAMES AND ADDRESSES

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Listed below are the names and addresses of the inventors for the above-identified patent application.

Ghassan E. JABBOUR

A declaration containing all the necessary information will be submitted at a later date.

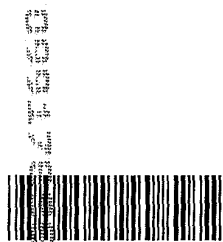
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